

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Haerle
Patent No. : 6,838,391 B2
Issue Date : January 4, 2005
Serial No. : 10/625,118
Filed : July 22, 2003
Title : METHOD OF SEMICONDUCTOR PROCESSING INCLUDING FLUORIDE

Art Unit : 2824
Examiner : Beth E. Owens

Attn.: Certificate of Corrections Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CERTIFICATE OF CORRECTION

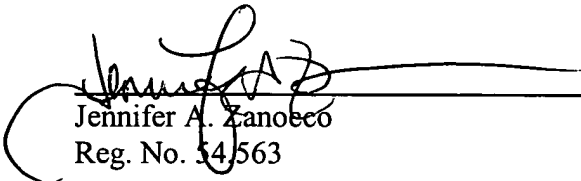
Applicant hereby requests that a certificate of correction be issued for the above patent in accordance with the attached request.

All errors sought to be corrected were made in printing by the Patent and Trademark Office, and no fee is believed to be due.

Please apply any unforeseen charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: March 7, 2005


Jennifer A. Zanoeco
Reg. No. 54,563

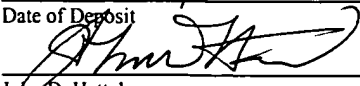
Fish & Richardson P.C.
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50264498.doc

Certificate
MAR 16 2005
of Correction

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 8, 2005
Date of Deposit

John D. Hettel

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Staple
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Only**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

PATENT NO. : 6,838,391 B2
DATED : JANUARY 4, 2005
INVENTOR(S) : VOLKER HÄRLE

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 1, under OTHER PUBLICATIONS, reference B. Henle,;

Replace:

"On Indium Phosphide & Rel. Materials, U.S. NY; IEEE, Bd."

with

-- *On Indium Phosphide & Rel. Materials, U.S. NY, IEEE, Bd.--*

On Page 2, under OTHER PUBLICATIONS, reference J.P. Harbinson et al.,

Replace:

J.P. Harbinson et al., *"Tungsten Patterning As A Technique"*

with

--J.P. Harbison et al., *"Tungsten Patterning As A Technique--*

On Page 2, under OTHER PUBLICATIONS, reference JP 02-046407,

Replace:

"JP 02-046407, Patent Abstracts of Japan, Veroffentlichung:"

with

--JP 02-046407, Patent Abstracts of Japan, Veroffentlichung:--

MAILING ADDRESS OF SENDER:

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INVENTOR(S) : VOLKER HÄRLE

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 2, under OTHER PUBLICATIONS, reference Whidden T.K. et al.;
Replace:

“Whidden T.K. et al.; *“Catalyzed HF Vapor Etcing Of”*
with
--Whidden T.K. et al.; *“Catalyzed HF Vapor Etching Of--*

On Page 2, under OTHER PUBLICATIONS, reference Wong M. et al.,;
Replace:

“*Oxide And Oxide Etching Using Vapor-Phase Hydrgoen*”
with
--*Oxide And Oxide Etching Using Vapor-Phase Hydrogen--*

In Column 5, at Line 29, in Claim 5,;
Replace:

“more from a group consisting of an underlying mask layer”
with
--or more from a group consisting of an underlying mask layer--

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INVENTOR(S) : VOLKER HÄRLE

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In Column 5, at Line 51, in Claim 7,;

Replace:

“defined an at least one (N+1)th semiconductor compo-”

with

--defined and at least one (N+1)th semiconductor compo---

In Column 6, at Line 29, in Claim 14,;

Replace:

“any remaining mask is moved by etching.”

with

--any remaining mask is removed by etching.--

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